

# Effects of UV-ozone photo-annealing on surface, electrical properties, and chemical bonds of BaTiO<sub>3</sub> thin films deposited by sol-gel method

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Barium titanate (BTO), an oxide with the perovskite structure that can be used as ferroelectric materials under Curie temperature, exhibits a wide bandgap of 3.2 eV indicating a promising insulating property [1]. To achieve a less complex and high permittivity, BTO combined with solution-process property was developed. Several approaches for the solution processing of thin film from various metal-organic precursors have been reported, including composition control, microwave annealing, the use of low-temperature-decomposable precursors, and deep-ultraviolet (DUV) photo-annealing. Among these methods, DUV photo-annealing is used in the present study due to high degrees of sol-gel condensation and film densification and thus improve thin film performance [2]. However, the effects of DUV photo-annealing on the properties of BTO films have not been investigated yet.

In this article, BTO thin films were deposited on pure p-type Si substrates by spin-coating. The dried, as-prepared films were photo-annealed by UV-ozone for 0–180 min, and then annealed in a tube furnace at 250 °C for 1 h. The optimized surface energy ( $\gamma_s$ ) (45.52 mJ/m<sup>2</sup>) is obtained for BTO with 150 min UV-ozone illumination, indicating the improvement of adhesion properties for followed metal deposition process [3]. For electrical measurement, Al films were deposited on the BTO film as metal/insulator/semiconductor (Al/BTO/Si) structure. The lowest leakage current density (5.66 × 10<sup>-12</sup> A/cm<sup>2</sup>) was also obtained.

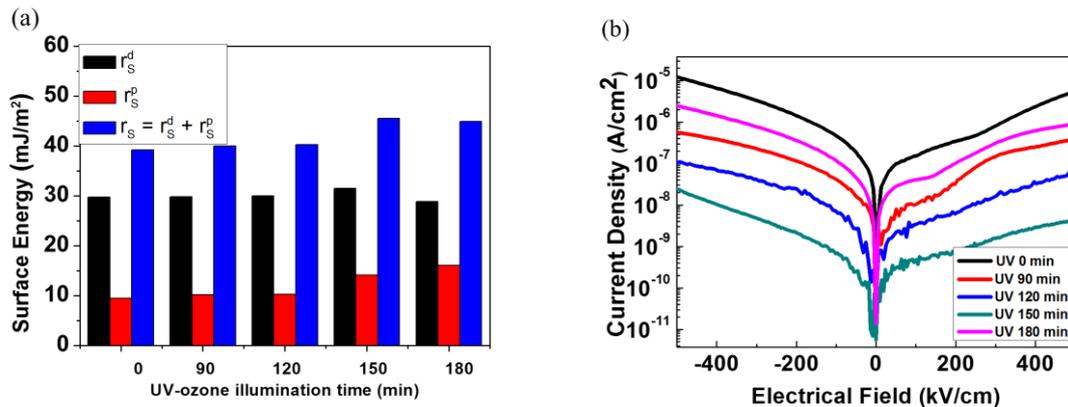


Fig. 1 (a) Surface energy ( $\gamma_s$ ) of BTO thin films as a function of UV-ozone treatment duration, (b) Leakage current density versus applied electric field (J–E) for the metal/insulator/semiconductor structure, and

In summary, UV-ozone-treated BTO thin film showed a high surface energy of 45.52 mJ/m<sup>2</sup>, low leakage current density of 5.66 × 10<sup>-12</sup> A/cm<sup>2</sup> compared with those of pristine BTO films (surface energy of 39.17 mJ/m<sup>2</sup>, leakage current density of 1.46 × 10<sup>-9</sup> A/cm<sup>2</sup>).

## References

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